

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named Inventor :	Benjamin Y.H. Liu et al.	Conf. No. 7978
Appln. No. :	10/769,011	
Filed :	January 30, 2004	Group Art Unit; 1763
For :	HIGH-PERFORMANCE AND MULTI-LIQUID-PRECURSOR VAPORIZATION IN SEMICONDUCTOR THIN FILM DEPOSITION	Examiner: R. Bueker
Docket No.:	M419.12-0043	

RESUBMITTED AMENDMENT IN RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Sir:

**VIA ELECTRONIC FILING
APRIL 29, 2008**

In response to the Notice of Non-Compliant Amendment dated April 14, 2008 and further in response to the Official Action Mailed September 7, 2007, it is respectfully requested that the following amendments be made.